



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent for:

Mark W. Miles

Serial No.: 10/074,562

Filed: February 12, 2002

For: METHOD FOR FABRICATING A STRUCTURE  
FOR MICROELECTROMECHANICAL  
SYSTEMS (MEMS) DEVICE

) Examiner: Barreca, Nicole M.

) Art Unit: 1756

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OCT 31 2003  
TC 1700

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Dear Sir:

In response to the Office Action dated 6/18/03, Applicant respectfully request that the above-identified application be amended as follows and that the following remarks be considered.

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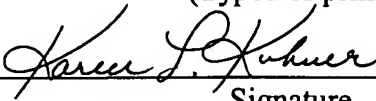
I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

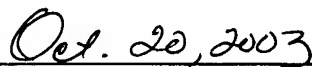
October 20, 2003

(Date of Deposit)

Karen L. Kuhner

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Signature

  
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